



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: **Gerald W. Gibson, Jr.**

Art Unit: **2823**

Serial No.: **10/675,572**

Examiner: **Toledo, Fernando L.**

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Attorney Docket No.: **Gibson 12/075903-208**

For: **Real Time Gate Etch Critical Dimension Control by Oxygen Monitoring**

**REQUEST FOR CONTINUED EXAMINATION AMENDMENT**

March 10, 2006

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Arlington, VA 22313-1450

Dear Sir:

This Amendment is submitted in conjunction with a Request for Continued Examination submitted on even date herewith for the above-identified patent application. The application stands finally rejected based on a final Office Action mailed on December 22, 2005.